

In re application of: Sharan et al.

Serial No.: 09/825,613

Filed: April 3, 2001

For: METHOD FOR PECVD

DEPOSITION OF SELECTED

MATERIAL FILMS

Group Art Unit: 2829

Examiner: Lisa Kilday

Atty. Docket: 95-0716.03

Certificate of Mailing (37 C.F.R.§ 1.8)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on the date below:

1/13/3 Date harles Browlley

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136(a)

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Commissioner for Patents Washington, D.C. 20231

Dear Sir:

Applicant hereby petitions to extend the period for response to the Office Action mailed September 12, 2002 for one (1) month(s), from December 12, 2002 to January 12, 2003.

Because <u>January 12, 2003</u> falls on a Sunday in the District of Columbia, the period for response extends to <u>January 13, 2003</u>.

Accordingly, the requisite fee is \$ 110. The Commissioner is requested to charge this fee, and any additional fee which may be required, to Micron Technology, Inc. Deposit Account 13-3092, Order No. 95-0716.03. A duplicate copy of this petition is enclosed.

Respectfully submitted,

Date: 1/13/3

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Charles B. Brantley, II, Reg. No. 38,086

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